



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

Michael T. Andreas

**Serial No.:** 10/665,238

**Filed:** September 17, 2003

**For:** METHOD FOR THE POST-ETCH  
CLEANING OF MULTI-LEVEL  
DAMASCENE STRUCTURES HAVING  
UNDERLYING COPPER  
METALLIZATION

**Confirmation No.:** 6261

**Examiner:** M. Lebentritt

**Group Art Unit:** 2824

**Attorney Docket No.:** 2269-5981US  
(02-1592.00/US)

**Notice of Allowance Mailed:**

January 5, 2005

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

March 17, 2005  
Date

Signature

Joseph A. Walkowski  
Name (Type/Print)

**AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)**

Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

**Amendments to the Specification appear on page 3 of this paper.**